



# 850nm VCSELs

## Log-normal shape in reliability analysis

---

Rubén Pérez-Aranda, KDPOF

# Wear-out reliability model — unreliability function



$$TTF_{x\%} = C \cdot J^{-n} \cdot \exp\left(\frac{E_a \cdot e}{k_B \cdot T_J}\right) = F^{-1}\left(\frac{x}{100}\right); \quad F(t) = \Phi\left(\frac{\ln(t) - \mu'}{\sigma'}\right)$$

$$F(t) = \int_0^t f(\tau) d\tau$$

$$f(t) = \frac{dF}{dt}(t), \quad f(t) \geq 0 \text{ for } \forall t \geq 0, \quad \int_0^\infty f(\tau) d\tau = 1$$

$$f(t') = \frac{1}{\sigma' \sqrt{2\pi}} \exp\left(-\frac{1}{2} \left(\frac{t' - \mu'}{\sigma'}\right)^2\right)$$

$$MTTF = \int_0^\infty \tau f(\tau) d\tau$$

$$TTF_{1\%} = F^{-1}(0.01)$$

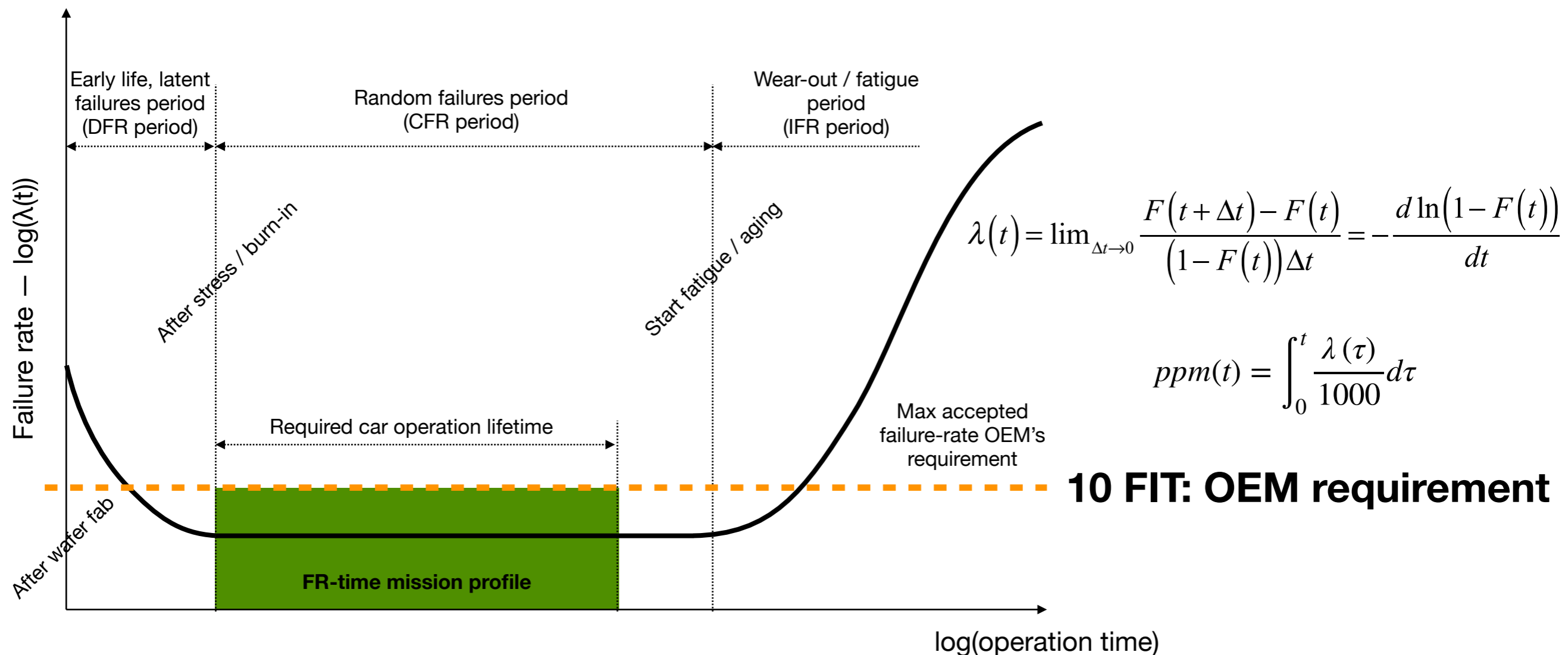
$$TTF_{50\%} = F^{-1}(0.5) = \exp(\mu')$$

$$TTF_{x\%} = \exp\left(\mu' + \sigma' \cdot \Phi^{-1}\left(\frac{x}{100}\right)\right)$$

- For a given  $t$ ,  $F(t)$  is the probability that failure occurs before  $t$
- $F(t)$  is the cumulative distribution function (CDF) of the failure probability
  - $\Phi$  is the standard normal distribution (i.e.  $N(0,1)$ )
  - $t$  is the time to failure
  - $t'$  is the natural logarithm of the time to failure
  - $\mu'$  mean of the natural logarithms of the time to failure
  - $\sigma'$  standard deviation of the natural logarithms of the time to failure
- Arrhenius's equation
  - $E_a$  is the activation energy of failure mechanism (eV)
  - $e$  is the electron charge (SI units)
  - $k_B$  is the Boltzmann's constant (SI units)
  - $T_J$  is absolute temperature (Kelvin)
  - $J$  is the current density (e.g. in kA/cm<sup>2</sup>)
  - $n$  is the current exponent
  - $C$  is a constant
  - $TTF_{x\%}$  is the time to  $x\%$  failures (e.g. in hours)

# Reliability model — failure rate

- Pay attention that **in general failure-rate  $\lambda(t)$  is not constant** and depends on how much time the component has survived in operation
- Failure-rate is typically measured in Failures In Time (FIT), number of failures per  $10^9$  (billion) **device-hours**
  - 1 FIT = probability of failure is  $10^{-9}$  / 1 hour (operation)
  - 1 FIT = probability of failure is 1 ppm / 1000 hours
  - 1 FIT = 1 failure per 1000 devices operating 1 million hours = 1 failure per 10 million devices operating 100 hours



# Wear-out reliability model — acceleration factors



$$\frac{TTF_1}{TTF_0} = \left| \exp \left( \frac{E_a e}{K_B} \left( \frac{1}{T_{J_1}} - \frac{1}{T_{J_0}} \right) \right) \right|_{J_1=J_0} \quad \frac{TTF_1}{TTF_0} = \left| \left( \frac{J_1}{J_0} \right)^{-n} \right|_{T_{J_1}=T_{J_0}}$$

$$\frac{TTF_1}{TTF_0} = \left| \left( \frac{A_0}{A_1} \right)^{-n} \right|_{I_1=I_0} = \left| \left( \frac{D_0}{D_1} \right)^{-2n} \right|_{I_1=I_0}$$

- Acceleration factors relate the times to failure between different conditions
  - We can calculate acceleration factor between two temperatures considering same current density condition
  - We can calculate acceleration factor between two current densities, considering same junction temperature
  - We can calculate acceleration factor between two oxide aperture diameters considering same junction temperature and the same bias current

# Reasons behind of a higher log-normal shape



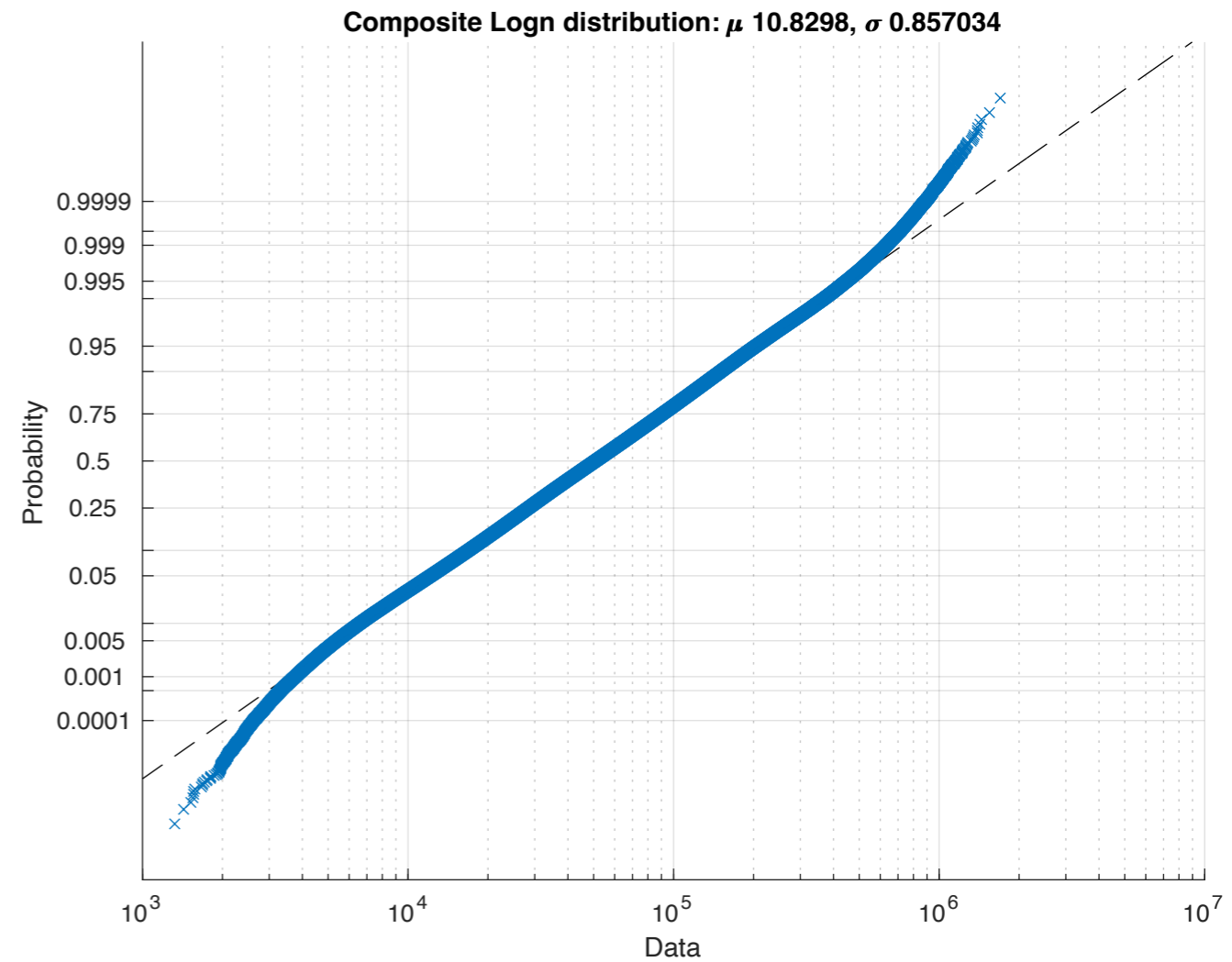
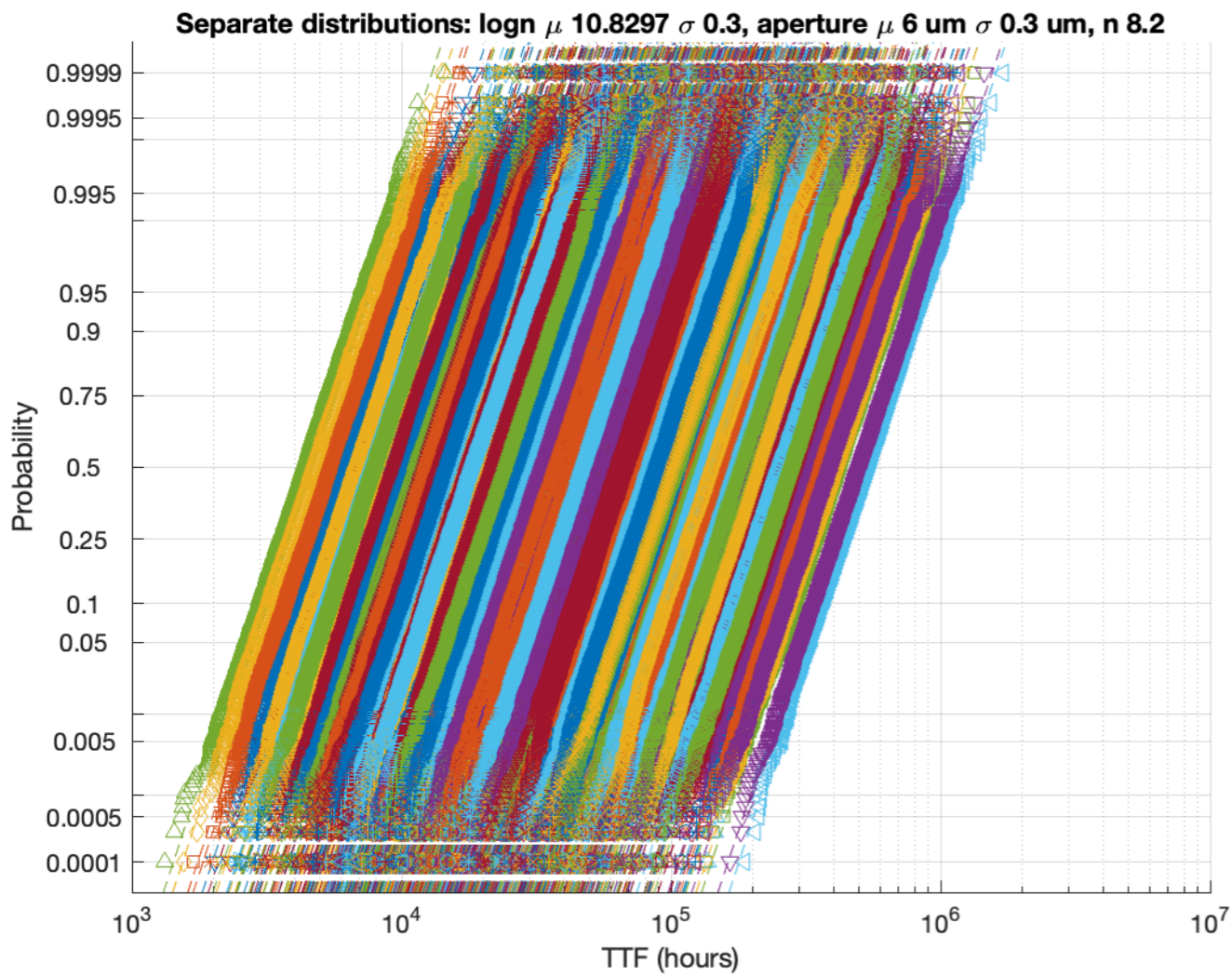
- Oxide aperture diameter is a parameter of VCSEL design that experiences deviation in the manufacturing process
  - There will be lot-to-lot variations
  - There will be wafer-to-wafer variations
  - There will be intra-wafer variations
- Wafer level test of VCSELs and final-test in assembled PHYs cannot detect oxide aperture deviations with low cost
  - Oxide aperture is usually tracked for each wafer by random sampling, much lower than 1%, i.e. only by measurement of some devices per wafer with limited precision
- Oxide aperture is not the only parameter affecting the log-normal shape
  - Even same oxide aperture devices will show different reliability when high volume and long term productions are considered
- VCSEL drivers bias current have production deviation (they do not have instrumentation precision)
- VCSEL manufacturers usually assume  $\sigma' > 0.5$  due to the above reasons

# Reasons behind of a higher log-normal shape



- As example, let's consider the oxide aperture diameter distributes in a wafer according to a normal distribution with mean  $\mu_D$  and standard deviation  $\sigma_D$
- Let's consider  $TTF_{50\%} = 50500$  hours ( $\mu' = 10.8297$ ) and shape  $\sigma' = 0.3$  at  $T_{BS} = 125^\circ\text{C}$  for oxide aperture diameter of  $\mu_D$  and current density exponent  $n$
- Let's consider a MC simulation:
  - 1000 log-normal distributions that result of considering 1000 different oxide aperture diameters from the normal distribution, each one with location  $\mu'$  calculated with the acceleration factor with respect to  $\mu_D$  and with shape  $\sigma' = 0.3$
  - 5000 runs (i.e. devices) for each log-normal
  - Composite log-normal distribution is calculated for  $5 \cdot 10^6$  devices
- Simulation results indicate that the location parameter is preserved, and shape is made wider

Example: aperture  $\mu_D = 6 \text{ um}$   $\sigma_D = 0.3 \text{ um}$ ,  $n = 8.2$





# Conclusions

---



- This contribution illustrates using mathematical analysis that log-normal shape parameter cannot be based on single populations
  - Single population reliability assessments are not reported in literature, not only for VCSEL failures but for the whole semiconductor industry
- Use of single population for reliability assessment requires the implementation of a quality control which is not currently implemented by the VCSEL industry
  - Actual 850nm VCSEL products do not meet automotive reliability requirements
  - Big effort would be needed to improve reliability of 850 nm devices
- The P802.3cz has selected the most suitable wavelength based on the standard reliability analysis
  - 980 nm is orders of magnitude more reliable than 850 nm
  - This has been widely reported by the industry
- Reliability needs to be considered with big margin
  - OEMs might need to adjust the mission profile increasing high temperature usage
- The standardization of a wide range wavelength, i.e. 840 ~ 990 nm, does not provide any benefit, but has many drawbacks
  - Cost is increased due to test in different wavelengths
  - Cost is increased due to the full optical link (cables and connectors) and receiver have to support the full wavelength range





Thank you